Electronic Acknowledgement Receipt				
EFS ID:	5414339			
Application Number:	10690507			
International Application Number:				
Confirmation Number:	6043			
Title of Invention:	Method for manufacturing polycrystalline silicon thin film and thin film transistor fabricated using polycrystalline silicon thin film manufactured by the manufacturing			
First Named Inventor/Applicant Name:	Ji Yong Park			
Customer Number:	49455			
Filer:	Randall Scott Svihla/Jennifer Oakley			
Filer Authorized By:	Randall Scott Svihla			
Attorney Docket Number:	0091.1032			
Receipt Date:	28-MAY-2009			
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Time Stamp:	16:04:39			
Application Type:	Utility under 35 USC 111(a)			

Payment information:

File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.)
1		775484 Amendment After Appeal _ 05-28	ves	8	
·		-09.pdf	3b4ba77194bedd18c0c852431518dcfacea 96287	'	

_	Multipart Description/PDF files in .zip description				
	Document Description	Start	End		
	Fee Worksheet (PTO-875)	1	1		
	Amendment/Argument after Notice of Appeal	2	2		
	Claims	3	6		
	Applicant Arguments/Remarks Made in an Amendment 7				
Warnings:					

Information:

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Total Files Size (in bytes):

New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.